

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 124683		APPLICATION NO. 10/542,147	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Hiroshi YAMADA et al.			
				FILING DATE September 6, 2005		GROUP 2816	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
BL	1.	4,539,054	09/03/1985	Kiyoshi MORIMOTO et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
BL	2.	JP-A-04-210463 w/ abst.	07/31/1992	JAPAN			
	3.	JP-A-07-166323 w/ abst. & trans.	06/27/1995	JAPAN			
	4.	WO 98/18167 A1	04/30/1998	WIPO			
	5.	JP-A-2002-047569 w/ abst. & trans.	02/15/2002	JAPAN			
	6.	JP-A-2001-064099 w/ abst. & trans.	03/13/2001	JAPAN			
	7.	JP-A-2002-324765 w/ abst. & trans.	11/08/2002	JAPAN			
	8.	JP-A-09-082996 w/ abst. & trans.	03/28/1997	JAPAN			
	9.	JP-A-02-260666 w/ abst.	10/23/1990	JAPAN			
	10.	JP-A-59-075682 w/ abst.	04/28/1984	JAPAN			
	11.	JP-A-2003-188100 w/ abst. & trans.	07/04/2003	JAPAN			
	12.	JP-A-2004-047601 w/ abst. & trans.	02/12/2004	JAPAN			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
BL	13.	Tsuyoshi YOSHITAKE et al.; "Hydrogenation of semiconducting amorphous FeSi ₂ "; <i>Japan Atomic Energy Research Institute, JAERI-Conf. 2002-014</i> ; January 2003; pp. 12-13. (w/ translation)					
EXAMINER				DATE CONSIDERED			
/Benjamin Liu/				05/09/2006			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: September 6, 2005